

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 11, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG642457741

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick (Faceted)

13%

46.5%

61%

63.3%

Pointed

Sample Image Used



COLOR

D E F G H I J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

IGI

1975

QR Code

© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT

July 11, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG642457741

Report verification at igi.org

PROPORTIONS

Medium To Slightly Thick (Faceted)

13%

46.5%

61%

63.3%

Pointed

Sample Image Used



COLOR

D E F G H I J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

IGI

1975

QR Code

© IGI 2020, International Gemological Institute

FD - 10 20

LABORATORY GROWN DIAMOND REPORT

July 11, 2024

IGI Report No LG642457741

OVAL BRILLIANT

9.22 X 6.59 X 4.17 MM

Carat Weight

Color Grade

Clarity Grade

Table

Girdle

Medium to Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG642457741

Report verification at igi.org